



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of  
Armbrust et al.

Serial No.: 09/666,325

Filed: September 21, 2000

Group Art Unit: 2811

Examiner: Kang, D.

For: SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED  
ADHESION/ELECTROMIGRATION

Assistant Commissioner of Patents  
Washington, D.C. 20231

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8/31/01  
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RESPONSE UNDER 37 C.F.R. §1.111

Sir:

In response to the Office Action mailed May 23, 2001, please consider the following:

REMARKS

Claims 15-34, all the claims pending in the application, stand rejected only on prior art grounds. Applicants respectfully traverse these rejections based on the following discussion.

**I. The Prior Art Rejections**

Claims 15-18, 21-24, and 27-32 stand rejected under 35 U.S.C. §103(a) as being anticipated by Filipiak (U.S. Patent No. 5,447,887), hereinafter "Filipiak", and claims 19-20, 25-26, and 33-34 stand rejected under 35 U.S.C. §103(a) as being unpatentable over Filipiak in view of Dass et al. (U.S. Patent 6,046,101) hereinafter "Dass". Applicants respectfully traverse these rejections based on the following discussion.

**CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)**

GAU2811

Applicant(s): ARMERUST et al.

Serial No. 09/666,325

AUG 27 2001

Filing Date  
September 21, 2000

Docket No.

BU9-98-110DIV

Examiner  
Kang, D.

Group Art Unit  
2811

Invention: SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED  
ADHESION/ELECTROMIGRATION

I hereby certify that this Response Under 37 C.F.R. 1.111  
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